



SDI Review Form 1.6

Journal Name:	Journal of Engineering Research and Reports
Manuscript Number:	Ms_JERR_49689
Title of the Manuscript:	A Study of Vacuum Efficiency for Silicon On Insulator Wafers
Type of the Article	

General guideline for Peer Review process:

This journal's peer review policy states that **NO** manuscript should be rejected only on the basis of '**lack of Novelty**', provided the manuscript is scientifically robust and technically sound. To know the complete guideline for Peer Review process, reviewers are requested to visit this link:

(<http://www.sciencedomain.org/page.php?id=sdi-general-editorial-policy#Peer-Review-Guideline>)

PART 1: Review Comments

	Reviewer's comment	Author's comment (if agreed with reviewer, correct the manuscript and highlight that part in the manuscript. It is mandatory that authors should write his/her feedback here)
Compulsory REVISION comments		
Minor REVISION comments		
Optional/General comments	Reviewer's comment: Dear Editor: The manuscript focused on the "A Study of Vacuum Efficiency for Silicon On Insulator Wafers". It is very interesting and novel study in Silicon fields. Based on above reason, it is recommended to publish it. However, some points need to revise, which is listed below [1] The Grammar and usage of English are needed to revise by Native English speaker. [2 The resolution of Figures 2, 5, and 6 is needed to improve it. Sincerely yours.	

PART 2:

	Reviewer's comment	Author's comment (if agreed with reviewer, correct the manuscript and highlight that part in the manuscript. It is mandatory that authors should write his/her feedback here)
Are there ethical issues in this manuscript?	<i>(If yes, Kindly please write down the ethical issues here in details)</i>	

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